Registr	ation No :	
210 <b>Total N</b>	210 210 210 210 210 210 210 210	B.Ted
	7 <sup>th</sup> Semester Back Examination 2018-19	MT440
	X - RAY AND ELECTRON MICROSCOPY	
	BRANCH: METTA, MME	
	Time : 3 Hours Max Marks : 70	
210	210 210 Q.CODE : <b>E533</b> 210 210	
	Answer Question No.1 which is compulsory and any FIVE from the rest.	
	The figures in the right hand margin indicate marks.	
Q1	Answer the following questions :	2 x 1
a)	Briefly mention the significance of Bragg's law in x-ray analysis?	,—
210 <b>b)</b>	What are the target metals used for XRD analysis? Mention their name with	
	respective wavelength?	
c)	Define resolution of microscope. How the resolution is related to the wavelength of the illumination system?	
d)	What changes you will get in XRD pattern when there is a transition from	
	order to disorder transformation?	
e)	What are the signals generated when X-ray interacts with sample?	
210 <b>f)</b>	What is the effect of spotsize on the resolution of the SEM image?	
g)	Why secondary electrons are mainly used for imaging in a SEM rather than the back scattered electrons?	
h)	Why STM (scanning tunneling microscope) is not applicable for	
i)	nonconductive sample and what do you mean by tunneling? Why lighter element cannot be detected by EDS?	
i)	What do you mean by texture?	
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Q2 a)	Derive the mathematical expression for $\lambda_{SWL}$ and voltage and also explain how	(5)
-	the intensity of X-ray varies with tube voltage?	
b)	What is structure factor? Calculate the structure factor for FCC unitcell?	(5)
Q3 a)	Explain any two diffraction methods and write down theirapplication?	(5)
210 <b>b)</b>	With the help of suitable diagrams briefly explain the generation of characteristic x-rays?	(5)
	Gharacteristic X-rays:	
Q4 a)	In a SEM, briefly explain the process of generation of at least five signals from	(5)
•	electron beam-specimen interaction?	
	Compare and contrast between EDS and WDS detector?	(5)
b)		
b) Q5 <sub>210</sub> a)	Explain the principle of residual stress measurement? 210 210	(5)

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210	Q6 a) b)	What is reciprocal la With the help of bloc ray diagram for bigh What is STM and it with neat sketch?	ck diagram ment t field imaging in	ion the major pai a TEM?	rts of a TEM ando	draw the (	5) 5) 0) <sup>210</sup>
210	Q8 a) b) c) 210 d)	Write short answer Write down the e interaction volume? Why filter is used in Explain working prin Write down any one	ffect of acceled XRD? ciple of Everhart	Thornley detect	or?		<b>x 2)</b> 210
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